Q3500.016294.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Eveninan Inva II Ansa
YASUO SUDA	: Examiner: Igwe U. Anya
Application No.: 10/630,680	: Group Art Unit: 2825
Filed: July 31, 2003	;
For: SEMICONDUCTOR DEVICE AND ITS MANUFACTURE METHOD	:) :) June 28, 2004

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to Japan 11-32169, which is listed on the enclosed Form PTO-1449. A copy of Japan 11-32169, together with an English-language abstract, is enclosed.

Japan 11-32169 was cited in an Official Action of a corresponding Korean application. A copy of the Official Action, which is dated May 25, 2004, is enclosed. (The Japanese-language version of the Official Action contains a typographical error. Japan 11-32169 is referred to as "Japan 11-302169" in the last paragraph.)

STATEMENT UNDER 37 C.F.R. § 1.97(e)

Each item of information in this Information Disclosure Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

FORMAL MATTERS

No fee is believed due; however, the Commissioner is hereby authorized to charge any fee which may be required in connection with this paper to Deposit Account No. 06-1205. A duplicate of this paper is enclosed for that purpose.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Attorney for Applicant Damond E. Vadnais Registration No. 52,310

FITZPATRICK, CELLA, HARPER & SCINTO 30 Rockefeller Plaza New York, New York 10112-3800 Facsimile: (212) 218-2200

FORM PTO 1449 (modified)				ATTY DOCKET NO. 03500.016294.1 APPLICATION NO. 10/630,680				
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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